



00862.022173

PATENT APPLICATION

#6 Suppl. IDS
DRAFTED
2-5-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:
Yasuhiro SHIMADA et al.
Application No.: 09/819,906
Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,
METHOD OF MANUFACTURING THE
SAME, CHARGED-PARTICLE BEAM
EXPOSURE APPARATUS, AND DEVICE
MANUFACTURING METHOD

Examiner: Unassigned
Group Art Unit: 2881

January 29, 2003

Commissioner for Patents
Washington, D.C. 20231

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

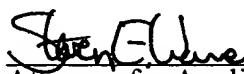
Further to the Information Disclosure Statement filed on October 23, 2001, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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SEW/eb